Electronic Patent Application Fee Transmittal							
Application Number:	10	10634662					
Filing Date:	04-Aug-2003						
Title of Invention:	RUTHENIUM LAYER FORMATION FOR COPPER FILM DEPOSITION						
First Named Inventor/Applicant Name:	Mei Chang						
Filer:	Anca Carmen Gheorghiu/Jo Ann Cottrell						
Attorney Docket Number:	005975/P1						
Filed as Large Entity							
Utility Filing Fees							
Description		Fee Code	Quantity	Amount	Sub-Total in USD(\$)		
Basic Filing:							
Pages:							
Claims:							
Miscellaneous-Filing:							
Petition:							
Patent-Appeals-and-Interference:							
Post-Allowance-and-Post-Issuance:							
Utility Appl Issue fee		1501	1	1400	1400		

Publ. Fee- early, voluntary, or normal

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Miscellaneous:							
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